



ITW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto IIDA

Group Art Unit: 1792

Application No.: 10/586,476 /

Examiner: G. RAO

Filed: July 18, 2006

Docket No.: 128768

For: A METHOD FOR PRODUCING SEMICONDUCTOR WAFERS AND A SYSTEM
FOR DETERMINING A CUT POSITION IN A SEMINCONDUCTOR INGOT

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the June 8, 2009 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.